IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s): Shin et al. Appl. No.: 10/661,439

Conf. No.: 7802

Filed: September 11, 2003

Title: METHOD FOR MANUFACTURING SEMICONDUCTOR DEVICE

Art Unit: 1763 Examiner: R. Zervigon Docket No.: 117597-002

United States Patent and Trademark Office

P.O. Box 1450

Alexandria, VA 22313-1450

SMALL ENTITY STATUS AND REQUEST FOR REFUND

Sir:

SMALL ENTITY STATUS:

Under 37 C.F.R. §1.27, Applicants request to be designated as small entity status.

REQUEST FOR REFUND:

On March 15, 2006, Applicants submitted a Three-Month Petition of Extension of Time for the above-identified patent application. The Petition included a filing fee payment of \$1,020.00. The filing fee payment was the amount due for a large entity. However, in view of the above establishment of small entity status, the small entity filing fee (\$510.00) is the correct fee due for that filing fee. Accordingly, Applicants request a refund of \$510.00 (\$1,020.00 paid - \$510.00 small entity fee equals \$510.00). Please credit deposit account number 02-1818 for the \$510.00 refund.

Applicants believe no fees are due for this submission. However, please charge deposit account number <u>02-1818</u> for any required fees for this submission. Applicants kindly request that the above-identified Attorney Docket No. <u>117597-002</u> be referenced with respect to the refund/credit and any charges made to the deposit account as discussed above.

Respectfully submitted,

Thomas C. Basso (46,541)

Cust. No. 24573

Date: April 21, 2006